L Number	Hits	Search Text	DB	Time stamp
1	25	(second adj stop) same stack same (trench or opening or contact)	USPAT; EPO; JPO; IBM TDB	2003/05/08 14:14
2	555	(second adj stop) and stack and (trench or opening or contact)	USPAT; EPO; JPO; IBM TDB	2003/05/08 · 14:16
3	849	(second adj stop) and (stack or stacked or stacking) and (trench or opening or contact)	USPAT; EPO; JPO; IBM TDB	2003/05/08
5 *	14	(second adj stop) and (stack or stacked or stacking) and (trench or opening or contact) and etch\$3 and polish\$3	USPAT; EPO; JPO; IBM TDB	2003/05/08
6	448	("silicon oxide" or SiO) and ("silicon nitride" or SiN) and "stop layer" and (stack or stacked or stacking) and (trench or opening or contact) and etch\$3	USPAT; EPO; JPO; IBM_TDB	2003/05/08 15:53
7	448	and polish\$3 (("silicon oxide" or SiO) and ("silicon nitride" or SiN) and "stop layer" and (stack or stacked or stacking) and (trench or opening or contact) and etch\$3 and polish\$3) and etch\$3	USPAT; EPO; JPO; IBM_TDB	2003/05/08 14:38
8	12718	(dielectric or insulating) same trench	USPAT; EPO; JPO; IBM TDB	2003/05/08 14:40
9	237	((("silicon oxide" or SiO) and ("silicon nitride" or SiN) and "stop layer" and (stack or stacked or stacking) and (trench or opening or contact) and etch\$3 and polish\$3) and etch\$3) and	USPAT; EPO; JPO; IBM_TDB	2003/05/08
10	464	((dielectric or insulating) same trench) ("silicon oxide" or SiO) and ("silicon nitride" or SiN) and ("stop layer" or "polish stop") and (stack or stacked or stacking) and (trench or opening or contact) and etch\$3 and polish\$3	USPAT; EPO; JPO; IBM_TDB	2003/05/08 16:06
11	5815	"shallow trench isolation" or STI	USPAT; EPO; JPO; IBM TDB	2003/05/08 16:07
12	138	(("silicon oxide" or SiO) and ("silicon nitride" or SiN) and ("stop layer" or "polish stop") and (stack or stacked or stacking) and (trench or opening or contact) and etch\$3 and polish\$3) and ("shallow trench isolation" or STI)	USPĀT; EPO; JPO; IBM_TDB	2003/05/08
13	1718		USPAT; EPO; JPO; IBM TDB	2003/05/08
14	25	(("silicon oxide" or SiO) and ("silicon nitride" or SiN) and ("stop layer" or "polish stop") and (stack or stacked or stacking) and (trench or opening or contact) and etch\$3 and polish\$3) and (((438/424) or (438/221) or (438/244) or (438/296) or (438/691)).CCLS.)	USPAT; EPO; JPO; IBM_TDB	2003/05/08 16:14